

# PATENT ASSIGNMENT

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NATURE OF CONVEYANCE:	ASSIGNMENT
CONVEYING PARTY DATA	
Name	Execution Date
Sharon Levin	11/02/2008
Alexey Heiman	10/30/2008
Zohar Kuritsky	11/02/2008
Gal Fleishon	11/02/2008
RECEIVING PARTY DATA	
Name:	Tower Semiconductor Ltd.
Street Address:	Ramat Gabriel Industrial Area
City:	Migdal Haemek
State/Country:	ISRAEL
Postal Code:	23105
PROPERTY NUMBERS Total: 1	
Property Type	Number
Application Number:	12260806
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**PATENT**

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ASSIGNMENT

For good and valuable consideration, receipt of which is hereby acknowledged, we

Sharon Levin of Ramat Gabriel Industrial Area (P.O. Box 619) Migdal Haemek, Israel 23105  
Alexey Heiman of Ramat Gabriel Industrial Area (P.O. Box 619) Migdal Haemek, Israel 23105  
Zohar Kuritsky of Ramat Gabriel Industrial Area (P.O. Box 619) Migdal Haemek, Israel 23105  
Gal Fleishon of Ramat Gabriel Industrial Area (P.O. Box 619) Migdal Haemek, Israel 23105

hereby sell, assign and transfer to **Tower Semiconductor Ltd.**, an Israeli corporation, having a place of business at Ramat Gabriel Industrial Area, Migdal Haemek, 23105 Israel, its successors and assigns, the entire right, title and interest throughout the world in our invention in

**"LDMOS TRANSISTOR HAVING ELEVATED FIELD OXIDE BUMPS  
AND METHOD OF MAKING SAME"**

for which a United States Patent Application Serial No. 12/260,806 was filed on October 29, 2008, and all patent applications and patents of every country for said invention, including divisions, reissues, continuations and extensions thereof, and all rights of priority resulting from the filing of said applications; we authorize the above-named assignee to apply for patents of foreign countries for said invention, and to claim all rights of priority without further authorization from us; we agree to execute all papers useful in connection with said United States and foreign applications, and generally to do everything possible to aid said assignee, their successors, assigns and nominees, at their request and expense, in obtaining and enforcing patents for said invention in all countries; and we request the Commissioner of Patents and Trademarks to issue all patents granted for said invention to the above-named assignee, its successors and assigns.

Executed this 2 day of November, 2008.

Sharon Levin

Signature Witness 1:  
(Print name)

Alon Eyal

Signature Witness 2:

Efraim Aharoni  
(Print name)

Executed this 30 day of October, 2008.

Alexey Heiman

Signature Witness 1:  
(Print name)

Ravit Forte

Signature Witness 2:

Shaul Mickelson  
(Print name)

Executed this 2 day of November, 2008.

Zohar Kuritsky

Signature Witness 1:  
(Print name)

Alon Eyal

Signature Witness 2:

Efraim Aharoni  
(Print name)

Executed this 2 day of November, 2008.

Gal Fleishon

Signature Witness 1:  
(Print name)

Alon Eyal

Signature Witness 2:

Efraim Aharoni  
(Print name)